



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Toshiya SATOH et al.

Serial No.:

09/809,181

Filed:

March 16, 2001

For:

SEMICONDUCTOR DEVICE AND MANUFACTURING

METHOD FOR HIGH RELIABILITY AND PRODUCTION YIELD RATE WITH MINIMAL DAMAGE DUE TO APPLICATION OF

MECHANICAL STRESS AND THERMAL STRESS

Group:

2815

Examiner:

Jose R. Diaz

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 August 19, 2004

Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within a twomonth time period subsequent to expiration of the shortened statutory period set in the outstanding Office Action mailed March 25, 2004. A credit card payment form in the amount of \$420.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (503.39864X00) and any excess fees credited to that account.

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420.00 DP

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

By

Hung H. Bui (Reg. No. 40,415)

Attorney for Applicant(s)

HHB:btd

1300 North Seventeenth Street, Suite 1800

Arlington, Virginia 22209

Tel.: (703) 312-6600 Fax: (703) 312-6666